

MAR 31 2008

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INFORMATION DISCLOSURE CITATION FORM FOR PATENT APPLICATION (FORM PTO-1449) (Substitute)		Docket No.: 884A.0120.U1(US)	Serial No.: 10/541,085		
		Applicant(s): Eldon et al.			
		Filing Date: 04/06/2006	Group: 2629		
U.S. PATENT DOCUMENTS					
Examiner Initials	Document Number (Number-Kind Code)	Publication Date (MM-DD-YYYY)	Name of Patentee or Applicant	Class	Sub-class
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	JP 2002-216570	02/08/2002	Semiconductor Energy Lab Co. Ltd	Translation /Abstract	
OTHER DOCUMENTS (Author (Capitalize), Title, Date, Pages, Etc., if known)					
Examiner's Signature: /Robert Rainey/			Date Considered: 07/01/2008		
Initial if reference was considered, whether or not citation is in conformance with MPEP. Mark through citation if not considered. Include a copy of this citation form with your next correspondence to the Applicant(s).					

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /R.R./